

3-29-01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: **Yoshiki SAKUMA**

Serial No.: **Not Yet Assigned**

Filed: **March 29, 2001**



For: **HETEROBIPOLAR TRANSISTOR AND A METHOD OF FORMING A SiGeC MIXED CRYSTAL LAYER**

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
Washington, D.C. 20231

March 29, 2001

Sir:

In compliance with 37 CFR 1.56, Applicant calls to the attention of the Patent and Trademark Office the references listed on the attached PTO-1449.

Copies of the references are enclosed herewith.

In the event there are any fees due in connection with the filing of this paper, please charge Deposit Account No. 01-2340.

Respectfully submitted,
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A handwritten signature in black ink, appearing to read "Donald W. Hanson".

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Enclosures: PTO-1449; References (8)